



Docket No.: 8734.013.D1 US
(PATENT)

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Se-Jin CHUNG

Confirmation No.: 4663

Application No.: 10/689,030

Group Art Unit: 1722

Filed: October 21, 2003

Examiner: Felisa C. Hiteshew

For: EXCIMER LASER CRYSTALLIZATION OF
AMORPHOUS SILICON FILM

Customer No.: 30827

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Mail Stop Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 6, 2005 (Paper No. 5689030), please amend the above identified U.S. Patent application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.